Launch Vehicle Avionics Passive Thermal Management

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A passive thermal management system was designed to cool avionics on a launch vehicle for 3 different thermal modes. Prior to launch, the heat sink for the avionics is purge duct flow. During the 10 minute launch period, the thermal energy is stored in phase change material (PCM). On orbit, the heat sink is a radiator. The system consists of 1. A high conductivity thermal shelf, 2. A PCM thermal storage system, 3. Heat pipes to conduct the heat from the shelf to the heat sinks, 4. Fins to reject the heat to the purge duct, and 5. A radiator to reject the heat on orbit. A unique aspect of the system design is the avionics shelf, which contains embedded heat pipes. While the electronics locations are fixed before manufacturing with encapsulated high conductivity material, this design allows the avionics boxes to be positioned anywhere. A second benefit is the much higher thermal effective thermal conductivity, which can approach 2500 W/m K in long systems. A low-cost, simplified version of the system to fabricated to verify the design during ground testing, consisting of the high conductivity plate, the heat pipe, and the purge duct sink. The general performance matched expectations, except that the overall ΔT was higher than expected, due to the thermal interface materials. This can be improved with a better material.

I. Introduction

NASA Marshall Space Flight Center requested a design for a passive thermal management system to cool avionics on a launch vehicle. As shown in Figure 1 and Figure 2, there are a series of aluminum shelves with avionics boxes. Parameters for the system are shown in Table 1. Any combination of minimum, average, and maximum size boxes can be placed anywhere on the shelf, as long as the maximum power (500 W) for the shelf is not exceeded. There are three different thermal modes:

- 1. Cooling for avionics while on ground prior to launch (indefinitely)
- 2. Cooling for avionics during launch (~10min)
- 3. Cooling on-orbit (indefinitely)

In pre-launch a nitrogen purge duct serves as the heat sink ($\sim 19.4^{\circ}$ C) for the thermal control device. The purge duct is located above the avionics, and along with the passive thermal system, must maintain the avionics boxes within the safe operating temperature range (-6.6 to 25.5°C). At lift-off the nitrogen purge ceases. The energy produced by the electronics during the ascent period of ~ 10 minutes must be stored. Finally, the heat generated on orbit must be rejected to space using an external radiator.

II. Thermal Management Subsystems

The thermal management system has 4 distinct subsystems:

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- 1. A heat collection system to collect the heat from the electronics boxes, and deliver it to a heat pipe
- 2. A thermal storage system, to accept the heat generated during ascent
- 3. A heat rejection system. On the ground, the heat is rejected through a series of fins to the purge air. On orbit, the heat is rejected with a radiator.
- 4. A heat transport system, consisting of riser heat pipes that transfer heat from the avionics shelf to the heat sink.



Figure 1: Purge Duct and Avionics Boxes



Figure 2: Purge duct routing concept

A. Heat Collection

If the heat source locations are known, then heat pipes could be designed to carry heat directly from the heat sources to the riser heat pipes. However, the electronics boxes (and heat sources) can be located anywhere on the shelves. In this case, the shelf must be designed with a high effective thermal conductivity. There are two options:

- 1. Encapsulated conduction cooling plates
- 2. High conductivity plates with embedded heat pipes.

1. Encapsulated Conduction Cooling Plates

The thermal conductivity of aluminum is about 200 W/m K. While copper has double the thermal conductivity, it is not used because its specific thermal conductivity is less than aluminum. Some metal composites and pyrolytic graphite have higher conductivities, but cannot be used by themselves, since they are often brittle, hygroscopic, and/or have relatively low strength. To minimize these problems, encapsulated conduction cooling plates have been

developed. A core of high conductivity material is encapsulated in a metallic shell to provide protection and strength.

Temperatures				
Baseplate Allowable Temperature Range	-6.6 to 25.5°C			
Purge Duct Nitrogen Sink	19.4 °C			
Purge Duct				
Aluminum, wall thickness:	1.6 mm (0.063 in.)			
Purge Duct Diameter	10 to 25 cm (4 to 10 in.)			
Purge Duct Length	20 to 96 cm (12 to 48 in.)			
Purge Duct Flow	8.5 to 51 m ³ /min (300 to 1800 cfm)			
Purge Flow Pressure Drop in Fin Stack	690 Pa (0.1 psid)/per shelf			
Avionics Shelf				
Maximum power per shelf	500 W			
Shelf Length	152 cm (60 in.)			
Shelf Width	46 cm (18 in.)			
Shelf Thickness	3.8 cm (1.5 in.)			
Avionics Boxes				
Maximum Power per box	175 W			
Maximum (Width x Depth x Height)	50 x 30 x 30 cm (20 x 12 x 12 in.)			
Average	30 x 30 x 30 cm (12 x 12 x 12 in.)			
Minimum	15 x 25 x 15 cm (6 x 10 x 6 in.)			

Table 1. Global Design Goals.

Encapsulated pyrolytic graphite plates have been used in spacecraft applications. While the in-plane thermal conductivity of pyrolytic graphite is 1000 to 1500 W/m K, the out-of-plane thermal conductivity is only 10 W/m K. Aluminum thermal vias are required to provide an interface between high heat flux components and the pyrolytic graphite. These locations are fixed during encapsulation, and lower the effective thermal conductivity. Due to the effects of the thermal vias, independent measurements have documented thermal conductivities around 550W/m-K with an aluminum encapsulant (Kugler, 2008). Encapsulated pyrolytic graphite is also expensive to manufacture, and the thermal conductivity drops after several hundred thermal cycles, as the encapsulant moves relative to the thermal vias. One set of tests reported that the effective conductance dropped by up to 12% (8% average) after ~220 thermal cycles between 100° C and -40° C. (Montesano, 2005)

Encapsulated pyrolytic graphite plates were dropped from further consideration due to:

- Expense. The parts must be hot isostatically pressed.
- Thermal conductivity: 550 W/m K is much lower than can be achieved with embedded heat pipes
- Fixed heat source locations. The via locations must be chosen prior to fabrication, which conflicts with the requirement to locate the boxes anywhere on the shelf.

2. High Conductivity (Hi-K) Plates with Embedded Heat Pipes

High conductivity (HiKTM) plates are aluminum plates with embedded heat pipes to increase the effective thermal Conductivity (Advanced Cooling Technologies, 2014) They are used in terrestrial cooling systems to collect heat from electronics, and either spread the heat or conduct it to a cold rail for cooling. A typical HiK plate has copper/water heat pipes embedded in a standard aluminum plate, using epoxy or solder; see Figure 3. The heat pipes are strategically placed to get good thermal results while not affecting current geometry or mounting features. The heat pipes and solder weigh slightly more than an aluminum baseplate (1.1 to 1.2 times more), but have effective thermal conductivities of 600 to 1200 W/m K for terrestrial systems, which is 3 to 6 times higher than aluminum. For longer, spaced-based systems, the effective thermal conductivity can be as high as 2500 W/m K, which is better than diamond. HiKTM plates can also be used as structural components within systems.

One of the limits of copper/water heat pipes is that they work best when the temperature is above $\sim 20^{\circ}$ C. At lower temperatures, the maximum heat pipe power decreases due to the sonic limit. At temperatures below the triple point, the water working fluid is frozen, and heat is only carried by conduction. While methanol can be used as the working fluid when lower operating temperatures are required, water is generally selected. With the proper working fluid charge (minimal free water in the heat pipe), these heat pipes can sustain thousands of freeze/thaw cycles without damage.



Figure 3. In one example, HiK^{TM} plates showed an experimental reduction of 22°C in peak temperature compared to a baseline aluminum plate. (a) Aluminum plate thermal analysis. (b) HiK^{TM} plate thermal analysis. (c) HiK^{TM} plate. Note that the heat pipes are tailored based on the electronics locations to give the maximum effective thermal conductivity.

B. Thermal Storage

At lift-off the nitrogen purge ceases. Three potential thermal solutions for the ascent period of ~10 minutes were considered:

- Phase Change Material (PCM)
- Hydride Thermal Storage
- Dumping the heat to the launch vehicle skin

Heat is released when hydrogen is absorbed by a metal hydride. Thermal energy can be stored by heating the hydrogen, and venting the hydrogen gas. (Park et al., 2007) A commonly used metal hydride, LaNi₅, has a theoretical heat storage capacity of 1200kJ/liter, while paraffin wax PCM material only has a heat storage capacity of 160-200kJ/liter. If hydride thermal storage is used, the volume and mass could be reduced by a factor of four or more. Hydride thermal storage was abandoned when a decision was made that venting was not acceptable. The launch vehicle skin is not a suitable skin structure, which leaves PCM as the best thermal solution during ascent.

C. Heat Rejection

In pre-launch a nitrogen purge duct serves as the heat sink (~19.4°C) for the thermal control device. The purge duct is located above the avionics, and along with the passive thermal system, must maintain the avionics boxes within the safe operating temperature range (-6.6 to 25.5° C). The purge flow rate and duct dimensions vary with circumference, from 96 m³/min with a 25 cm diameter duct, to 8.5 m³/min with a 10 cm diameter duct. The maximum allowable pressure drop through the purge duct is 690 Pa (0.1 psid) per shelf for nitrogen flow rates between 300 and 1800 SCFM. While on-orbit the electronics radiate to space using an external radiator. Fuel was considered, but is not feasible as a long term heat rejection solution.

D. Heat Transport System

Heat collected by the shelf from the avionics boxes is carried by a series of aluminum/ammonia Constant Conductance Heat Pipes (CCHPs) to the two sinks, fins in the purge duct during pre-launch, and to an external radiator on orbit. Depending on the mission, it may be necessary to use Variable Conductance Heat Pipes (VCHPs) to keep the electronics above 6.6°C in certain orbits.

III. System Design

The overall thermal management system, shown in Figure 4, has the following components:

- High Conductivity (HiKTM) Plate, where the avionics are mounted
- Three Constant Conductance Heat Pipe (CCHP) Header Heat Pipes
- Finned Heat Exchanger, the designated heat sink during pre-launch.
- Phase Change Material, the designated heat sink during ascent.
- Radiator, the designated heat sink on orbit.



Figure 4. Thermal management system for a single avionics shelf.

The purge duct temperature would need to be reduced slightly for this concept, since it requires the avionics boxes to operate below the melting temperature of the PCM during pre-launch and then rise above the melting temperature during launch. With the current ΔT of ~6.1°C between the maximum allowable electronics temperature and the purge flow sink, this is difficult to achieve. The problem can be alleviated by slightly reducing the purge sink temperature during pre-launch, and/or operating the avionics slightly above their maximum allowable temperature during the 10 minute launch period. Since cost and feasibility were considered dominant factors of the design, a request for such changes in the design requirements was considered reasonable.



E. Avionics Shelf Design

The Hi-K plate geometry used throughout the thermal analysis consisted of a 50.8 x 45.7 x 0.64 cm (20 x 18 x 0.25 in.) 6061 aluminum plate. The one-third plate module has a total of 51 fully embedded copper/water heat pipes (OD = 0.635 cm (0.25 in), average length = 28.6 cm (11.25 in), wall thickness = 0.51 mm (0.02 in)) in a spreading pattern. The partial assembly also has an aluminum/ammonia CCHP header (OD = 2.54 cm (1in)) with flange width of 6.35 cm (2.5 in) and a flange thickness of 3.2 mm (0.125 in.).

Due to the broad nature of the design requirements of the trade study it was necessary to establish an appropriate set of test conditions that covered the range of expected heat load locations, while also minimizing the number of cases to consider in the thermal analysis. The heat load conditions were classified as the "worst-case", "medium-case", and "best case", as seen in Figure 6. In all cases, the heat loads (i.e. avionics boxes) were assumed to generate the maximum expected heat load (175W) and located symmetrically with respect to the plate width. Again, only one third of the total Hi-K plate was considered due to symmetry. The "worst-case" heat load consists of the smallest avionics box (i.e. highest heat flux) located at the edge of the Hi-K plate. The "medium-case" heat load also has the highest possible heat flux, but it is centered over the evaporator section of the CCHP header. The "best-case" heat load consists of the largest box (i.e. lowest heat flux), which consumes the entire length and most of the width of the plate portion under consideration.



Figure 7: Results of Hi-K plate thermal analysis for 3 heat load cases

Figure 7 shows the results of the numerical analysis performed with Autodesk CFD Simulation for the three heat load scenarios for the optimized Hi-K plate design. The low temperature boundary condition (represented as the vapor temperature of the CCHP header) was assumed to be at ~23.3°C and located at the cut surface of the CCHP header.

The primary interest of this analysis was the temperature differences between the heat loads and the CCHP vapor; since this quantity dictates the remaining delta T that will be available to transport the heat load to the purge duct sink. The temperature difference was $\sim 2.0^{\circ}$ C for the "worst-case" scenario, $\sim 1.4^{\circ}$ C for the "medium-case" scenario, and $\sim 1.1^{\circ}$ C for the "best-case" scenario. These results indicate that there will be at least a $\sim 4.1^{\circ}$ C temperature difference to facilitate heat transfer from the CCHP header to the purge duct sink using the most conservative estimate.

F. Heat Sink during Launch – Phase Change Materials (PCM)

In order to prevent the avionics from over-heating during launch a heat sink must be able to accept 500W of heat from a shelf for ~10 minutes (i.e. 300kJ). PCM was selected as the heat sink during launch. A trade study on various phase change materials was conducted to help with the material selection process. The salt hydrate material (Rubitherm, SP25A08) was chosen primarily because the melting temperature of the material ($25^{\circ}C$)was near the avionics operating temperature and the latent heat of fusion was reasonably large (160 kJ/kg).

The PCM mass is relatively small and the PCM was spread over half of the bottom of each one-third of the shelf, centered around the header heat pipes. The conductivity was enhanced with aluminum fins, each 0.5 mm (0.020 in.) thick, 5.7 mm (0.225 in.) with a PCM thickness of 2 mm (0.080 in.).

G. System Mass

The mass breakdown for a single avionics shelf is given in Table 2.

	Component		Mass
Component Description	Mass (kg)	Quantity	(kg)
Al Hi-K Plate (0.25")	7.38	1	7.38
Embedded Cu Pipes	0.06	153	9.18
Embedded Ti Pipes	0.02	153	3.06
Al/NH3 CCHP Header	1.09	3	3.27
Total PCM Package	0.93	3	2.80
Al Finned Stack (for duct)			
300CFM	0.40	3	1.21
Al Finned Stack (for duct)			
1800CFM	0.49	3	1.48
Radiator Panel	13.50	1	13.50
Embedded Al Pipes for Radiator	NA	20	3.60
Total Mass w/ Cu Pipes (kg)			42.42
Total Mass w/ Ti Pipes (kg)			36.30

Table 2. System mass for a single avionics shelf.

IV. Thermal Stackup

The thermal stackup of the system during pre-launch, launch, and on-orbit is shown in Figure 8. The pre-launch ΔT stackup is for the "worse-case" heat loading condition. For this case, the ΔT s for both the 300 and 1800CFM purge flow conditions are included. A temperature drop of 1°C was assumed for the vapor within the CCHP header; however, this was a conservative estimate since the heat pipe vapor is usually considered isothermal.

The upper right area of Figure 8 shows the layout of the PCM and the corresponding temperature drop between the avionics and PCM for the "worse-case" heat loading condition. This figure indicates that the avionics operating temperature would need to exceed the maximum allowable temperature (~25.5°C) in order to completely melt the selected PCM. The lower section of Figure 8 shows the thermal stack-up for on orbit conditions. The stack-up is based on the "worse-case" heat load condition and the highest expected sink temperature.



Figure 8. Predicted temperature profile of the avionics thermal solution during pre-launch, ascent and onorbit operational conditions.

Figure 9 illustrates how the avionics temperature changes throughout the pre-launch, launch, and orbit conditions in order for the chosen design concept to work properly. During pre-launch, the avionics temperature must operate at least 2°C below the lower melting temperature of the PCM to ensure the PCM remains in the solid state. As result, the sink temperature must be reduced by approximately the same amount, since the temperature gradient can be reasonably assumed to be linear throughout the system. Once launch begins, the avionics temperature must rise slightly above the maximum allowable temperature (i.e. 25.5°C) in order to melt the selected PCM. However, the avionics should only experience this temperature rise during the 10 minute ascent period. When the vehicle is in orbit, the avionics temperature will be reduced to within its nominal operating temperature range.



Figure 9: Summary of thermal stack-up

The necessary reduction of the sink temperature (addressed in Figure 9) will probably need to be reduced $\sim 2^{\circ}$ C (i.e. from 17.9 to 15.9°C). This discrepancy was the result of not accounting for the thermal interface resistance

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between the CCHP header flange and the Hi-K plate in the thermal analysis of the Hi-K plate. The requirement for the increase in avionics temperature during launch should not be affected by this discrepancy, since the CCHP header can be assumed to be inactive during this time; hence the delta T of the interface will be insignificant.

V. Experimental Design and Fabrication

A low-cost, simplified version of the system was fabricated to verify the design during ground testing. It consisted of:

- High Conductivity Plate, or embedded heat pipe HiK plate.
- Associated header heat pipe with appropriate interfaces on the condenser end to transport collected heat to externally provided heat sinks that simulate either ground cooling or in-space cooling.
- Removable Purge Flow Fin Heat Exchanger (ranging from modular fins for duct cooling with a flange for attachment to a radiator to a flange only to support a variety of heat rejection methods).

Design requirements for the system are given in Table 3. It is one-third of the complete avionics shelf, with one heat pipe.





Figure 10. Heat Sink in Duct.

Avionics HiK Shelf				
Heat Load	175 W			
Avionics Max. Heat Flux Density	$0.51 \text{ W/cm}^2 (3.3 \text{ W/in}^2)$			
Maximum Avionics Surface Temperature	26°C			
Avionics Shelf	50.8 x 45.7 cm (20 x 18 in.)			
Bolt hole pattern for avionics boxes	2 in. x 2 in. bolt hole pattern			
Heat Sink				
Flow Rate	8.5 m ³ /min (300 scfm)			
Purge Flow Temperature	18 C			
Duct Diameter	10.2 cm (4 inch)			
Maximum pressure drop	690 Pa (0.1 psid)			
Heat Exchanger (Duct Length)	anger (Duct Length) Less than 30.5 cm (12 in.)			
Vertical Distance for Heat Transport	122 cm (48 in.)			

The HiK plate has 36 embedded heat pipes. The copper/water heat pipes were flattened to fit in the plate, with an initial O.D. of 6.35 mm (0.25 in.) As shown in Figure 11, the heat pipes are laid out to avoid the mounting bolt holes.



Figure 11. HiK Plate Instrumentation. The locations of the straight heat pipes embedded in the plate can be seen.

VI. Preliminary Testing

Preliminary tests were conducted at ACT to verify functionality and to correlate the experimental data with the models. The experimental test setup is shown in Figure 12 and Figure 12. Electrical heaters applied 175 W (0.51 W/cm^2) over a 7.6 x 35.7 cm ($3 \times 18 \text{ in.}$) strip at the edge of the plates (worst case).



Figure 12. HiK Plate/CCHP/Heat Sink/Duct test set-up.



Figure 13. With the CCHP evaporator located in the center of the plate. 175 W (0.51 W/cm^2) was applied over a 7.6 x 35.7 cm (3 x 18 in.) strip at the edge of the plates.

	Test 1	Test 2
HiK Plate to Heat Pipe	5.87°C	5.58°C
Heat Pipe Length	2.69°C	2.56°C
Heat Pipe to Air	6.58°C	6.34°C
Overall, Plate Surface to Air	15.13°C	14.40°C

Table 4. Preliminary Experimental Test Results.

Tests results are shown in Table 4. The high level goal for this program is to develop an avionics thermal management system with an overall thermal gradient of near 6°C. The low-cost proof of concept system developed under this program demonstrated that certain elements of the total system stack up are conducive to a 6°C system. The header CCHP performed in both the reflux and 0.1" adverse tilt orientation with only a 2.7°C gradient.

Much of the overall ΔT is due to the thermal interface materials (TIMs), between the HiK plate and the CCHP, and the CCHP and the Heat Sink.

The TIM was Nusil CV2-2646 for all the make/break joints. This is a low outgassing RTV silicone, with a thermal conductivity of 1.50 W/m K. The measured ΔT of roughly 15°C was above the predicted value of 13.5°C.

For this assembly, the individual components were designed to be disconnected readily from one another. Alternate thermal interface materials are commercially available that would result in a higher thermally conductive interface with added difficultly for disassembly. A common flight adhesive is Eccobond 56C with Cat 9. This product is a two part silver filled epoxy. The finned heat exchanger was designed based on commercially available off the shelf extrusion stock. A higher efficiency, custom design could be developed and machined to reduce the gradient between the nitrogen and the header heat pipe. An optimized fin thickness, fin height, and fin length could be developed to improve the efficiency of the heat exchanger. Additionally, embedded heat pipe technology could also be employed to further isothermalize the heat exchanger.

After preliminary testing at ACT for functional testing and model correlation, the assembly was delivered to Marshall Space Flight Center for subsequent integrated system level testing in ambient and thermal vacuum conditions at MSFC.

VII. Conclusion

A passive thermal management system was designed to cool avionics on a launch vehicle for 3 different thermal modes

1. Cooling for avionics while on ground prior to launch (indefinitely), dumping the heat to flow in a purge duct.

- 2. Cooling for avionics during launch (~10min), storing the heat in a PCM module
- 3. Cooling on-orbit (indefinitely), with a radiator.

The system has the following components

- High Conductivity (HiKTM) Plate with embedded heat pipes, where the avionics are mounted
- Three Constant Conductance Heat Pipe (CCHP) Header Heat Pipes, that transfer heat to the purge duct of the radiator

- Finned Heat Exchangers, the designated heat sink during pre-launch.
- PCM modules, the designated heat sink during ascent.
- Radiator, the designated heat sink on orbit.

A unique aspect of the system design is the avionics shelf, which contains embedded heat pipes. While the electronics locations are fixed before manufacturing with encapsulated high conductivity material, this design allows the avionics boxes to be positioned anywhere. A second benefit is the much higher thermal effective thermal conductivity, which can approach 2500 W/m K in long systems.

A low-cost, simplified version of the system (one of three modules) was designed and fabricated to verify the design during ground testing. It consisted of the HiK plate, the heat pipe from the plate to the simulated duct, and a simple, low cost heat sink inside of the simulated duct. The measured ΔT of roughly 15°C was above the predicted value of 13.5°C, due to the thermal interface material, which was chosen for easy disassembly. The overall thermal performance can be improved with a better interface material.

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